

SUBSTITUTE FORM PTO-1449
(MODIFIED)INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(Use several sheets if necessary)

(37 CFR 1.98(b))

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
MTCL/09SERIAL NO.
10/613,620APPLICANT
David FairbournFILING DATE
July 3, 2003GROUP
1763

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER							ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
EF	A.A	4	2	6	4	6	8	2	4/28/1981	Fuyama et al.	428	336	7/2/1979
EF	A.B	5	4	0	7	7	0	4	4/18/1995	Basta et al.	427	248.1	8/26/1993
EF	A.C	5	4	0	7	7	0	5	4/18/1995	Vakil	427	255	3/1/1993
	A.D												
	A.E												
	A.F												
	A.G												
	A.H												
	A.I												
	A.J												
	A.K												

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLASS	TRANSLATION (YES/NO)
EF	A.L	55-058365	5/1/1980	JP	C23C 11/08		Abstract Only
	A.M						
	A.N						
	A.O						
	A.P						
	A.Q						

OTHER DOCUMENTS (Including Author, Title, Date, Place of Publication)

EF	A.R	Derderian et al., <u>United States Patent Application Publication No. US 2003/0032283</u> , Publication Date: 2/13/2003
EF	A.S	Wames et al., <u>United States Patent Application Publication No. US 2003/0049374</u> , Publication Date: 3/13/2003
	A.T	

EXAMINER

DATE CONSIDERED


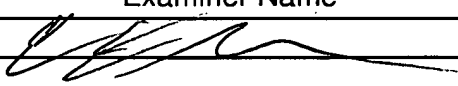
11/7/03

EXAMINER: Initial if citation considered, whether or not in conformance. Draw line through citation only if not in conformance and not considered. Include a copy of this form with next communication to applicant.

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	Simple Chemical Vapor Deposition System and Methods for Depositing Multiple-Metal Aluminide Coatings						
<div>Application Number : 10/613620 </div> <div>Confirmation Number: 4378</div> <div>First Named Applicant: Fairbourn David</div> <div>Attorney Docket Number: MTCL-09</div> <div>Art Unit: 1763</div> <div>Examiner: Eric B Fuller</div> <div>Search string: (6689422).pn</div>							
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
EP	1	6689422	2004-02-10	Warnes et al.	B1	427	255.11
Signature							
Examiner Name				Date			
				11/2/05			



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of
Invention

Simple Chemical Vapor Deposition System and Methods for
Depositing Multiple-Metal Aluminide Coatings

Application Number: 10/613620



Confirmation Number: 4378

First Named Applicant: David Fairbourn

Attorney Docket Number: MTCL09

Search string: (2598957 or 2816048 or 3329601 or 3486927
or 3507248 or 3556744 or 3801357 or 3979534
or 4084025 or 4101714 or 4220460 or 4327134
or 4396213 or 4427720 or 4641603 or 4625678
or 4694036 or 4699084 or 4687684 or 4816291
or 4961958 or 4935193 or 4963395 or 5071678
or 5114559 or 5261963 or 5308399 or 5368648
or 5377429 or 5439525 or 5451258 or 5455071
or 5632820 or 5750436 or 5820641 or 5823416
or 5851293 or 5902406 or 6083321 or 6089184
or 6143361 or 6156123 or 6254983 or 6258461
or 6332926 or 6605161).pn.

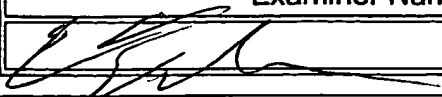
US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
EP	1	2598957	1952-06-03	Wolfe		312	100
	2	2816048	1957-12-10	Galmiche		117	107
	3	3329601	1967-07-04	Mattox		204	298
	4	3486927	1969-12-30	Gauje		117	107.2
	5	3507248	1970-04-21	Seeley et al.		118	48
	6	3556744	1971-01-19	Berkley et al.		29	183.5
	7	3801357	1974-04-02	Baldi		117	107.2
	8	3979534	1976-09-07	Rairden, III		427	405
	9	4084025	1978-04-11	Rairden, III		427	229
	10	4101714	1978-07-18	Rairden, III		428	639
	11	4220460	1980-09-02	Partus		65	3
EP							

12	4327134	1982-04-27	Baldi	427	253	
13	4396213	1983-08-02	Hawkins	285	287	
14	4427720	1984-01-24	Gauje	427	237	
15	4641603	1987-02-10	Miyazaki et al.	118	724	
16	4625678	1986-12-02	Shioya et al.	118	723	
17	4694036	1987-09-15	Baldi	524	473	
18	4699084	1987-10-13	Wilson et al.	118	725	
19	4687684	1987-08-18	Restall et al.	427	248.1	
20	4816291	1989-03-28	Desphandey et al.	427	38	
21	4961958	1990-10-09	Desphandey et al.	427	38	
22	4935193	1990-06-19	Grunke et al.	427	12	
23	4963395	1990-10-16	Lewis et al.	427	253	
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25	5114559	1992-05-19	Ohta et al.	204	298.05	
26	5261963	1993-11-16	Basta et al.	118	724	
27	5308399	1994-05-03	Pillhoefer et al.	118	719	
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30	5439525	1995-08-08	Peichl et al.	118	726	
31	5451258	1995-09-19	Hillman et al.	118	715	
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33	5632820	1997-05-27	Taniyama et al.	118	724	
34	5750436	1998-05-12	Yamaga et al.	438	558	
35	5820641	1998-10-13	Gu et al.	55	269	
36	5823416	1998-10-20	Haji	228	4.5	
37	5851293	1998-12-22	Lane et al.	118	715	
38	5902406	1999-05-11	Uchiyama et al.	118	724	
39	6083321	2000-07-04	Lei et al.	118	719	
40	6089184	2000-07-18	Kaizuka et al.	118	723	
41	6143361	2000-11-07	Near et al.	427	248.1	
42	6156123	2000-12-05	Pillhoefer et al.	118	715	
43	6254983	2001-07-03	Namiki	B1	428	336
44	6258461	2001-07-10	Baldi et al.	B1	428	469
45	6332926	2001-12-25	Pfaendtner et al.	B1	118	721
46	6605161	2003-08-12	Fairbourn	B2	148	243

Signature

Examiner Name	Date
	11/17/05